
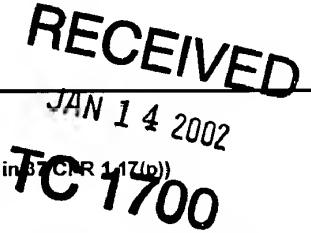
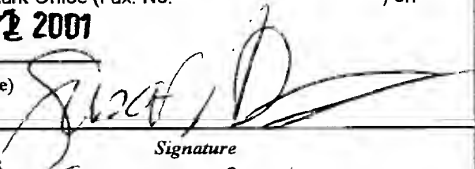
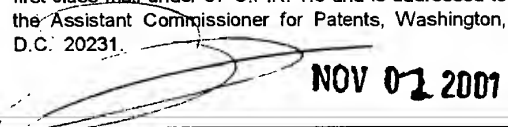
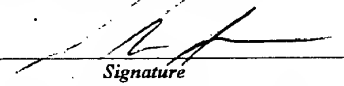


#4 1765
#4

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT (Under 37 CFR 1.97(b) or 1.97(c))		Docket No. 004227 USA02/ETCH	
In Re Application: David Mui et al.		COPY OF PAPERS ORIGINALLY FILED SILICON/JSB	
Serial No. 09/905,172	Filing Date 7/13/01	Examiner Unassigned	Group Art Unit 1765
ETCH PATTERN DEFINITION USING A CVD ORGANIC LAYER AS AN ANTI-REFLECTION COATING AND MASK			
			
Payment of Fee (Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(b))			
<input type="checkbox"/> A check in the amount of _____ is attached. <input checked="" type="checkbox"/> The Assistant Commissioner is hereby authorized to charge and credit Deposit Account No. 50-1074 as described below. A duplicate copy of this sheet is enclosed. <input type="checkbox"/> Charge the amount of _____ <input type="checkbox"/> Credit any overpayment. <input checked="" type="checkbox"/> Charge any additional fee required.			
Certificate of Transmission by Facsimile*		Certificate of Mailing by First Class Mail	
<div>I certify that this document and authorization to charge deposit account is being facsimile transmitted to the United States Patent and Trademark Office (Fax No. _____) on NOV 02 2001 (Date)  Signature Susan Antunes Typed or Printed Name of Person Signing Certificate</div>		<div>I certify that this document and fee is being deposited on _____ with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231. NOV 02 2001  Signature of Person Mailing Correspondence Susan Antunes Typed or Printed Name of Person Mailing Certificate</div>	
*This certificate may only be used if paying by deposit account.			
 Signature Joseph Bac Reg. # 37,711		Dated: 11/1/01	
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TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT
(Under 37 CFR 1.97(b) or 1.97(c))

Docket No.
004227 USA02/ETCH/

In Re Application Of: **David Mui et al.**

SILICON/J81

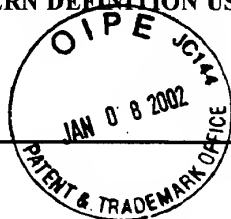
Serial No.
09/905,172

Filing Date
7/13/01

Examiner
Unassigned

Group Art Unit
1765

Title: **ETCH PATTERN DEFINITION USING A CVD ORGANIC LAYER AS AN ANTI-REFLECTION COATING AND HARDMASK**



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Address to:
Assistant Commissioner for Patents
Washington, D.C. 20231

37 CFR 1.97(b)

1. ☒ The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.

37 CFR 1.97(c)

2. ☐ The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:

☐ the statement specified in 37 CFR 1.97(e);

OR

☐ the fee set forth in 37 CFR 1.17(p).